

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of
Shoriki NARITA et al.
Serial No. 09/988,704
Filed November 20, 2001

: Confirmation No. 9134
: Attorney Docket No. 2001_1718A
: Group Art Unit 2625
: Examiner Sheela Chawan

METHOD AND APPARATUS FOR
CORRECTING INCLINATION OF IC ON
SEMICONDUCTOR WAFER

ADDITIONAL CLAIMS FEE TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Transmitted herewith is an Amendment in the above-identified application. Additional fees required as a result of this Amendment are calculated as follows:

	SMALL ENTITY	LARGE ENTITY	
Indep. Claims exceeding 3 (not already paid for): 3 x	(\$100 = \$)	or	(\$200 = \$600.00)
Total Additional Fee =	\$	or	<u>\$600.00</u>

[X] A check in the amount of \$600.00 is enclosed.

Respectfully submitted,

Shoriki NARITA et al.

By

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November 18, 2005



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Shoriki NARITA et al. : Attorney Docket No. 2001_1718A
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AMENDMENT

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Responsive to the Office Action dated July 27, 2005, the period for response to which having been extended by one-month to November 27, 2005, please amend the above-identified application as follows.

11/21/2005 JADDO1 00000075 09988704

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